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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/630,640	07/29/2003	William Dale Jones	SSI-08200	8274
28960	7590	11/30/2006	EXAMINER	
HAVERSTOCK & OWENS LLP			STINSON, FRANKIE L	
162 NORTH WOLFE ROAD			ART UNIT	
SUNNYVALE, CA 94086			PAPER NUMBER	

1746

DATE MAILED: 11/30/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

10/630,640

Applicant(s)

JONES

Examiner

FRANKIE L. STINSON

Art Unit

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 16 October 2006.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-30 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1-20 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
 - ☐ Certified copies of the priority documents have been received in Application No. _____.
 - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☐ Information Disclosure Statement(s) (PTO/SB/08)
Paper No(s)/Mail Date _____
- 4) ☐ Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____
- 5) ☐ Notice of Informal Patent Application
- 6) ☐ Other: _____

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1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

1. Claims 1, 8, 10-16, 19, 20, 23, 25 and 27-29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gopinath et al (U. S. Pat. No. 6,951,765) in view of Japan'679 (Japan 7-24679).

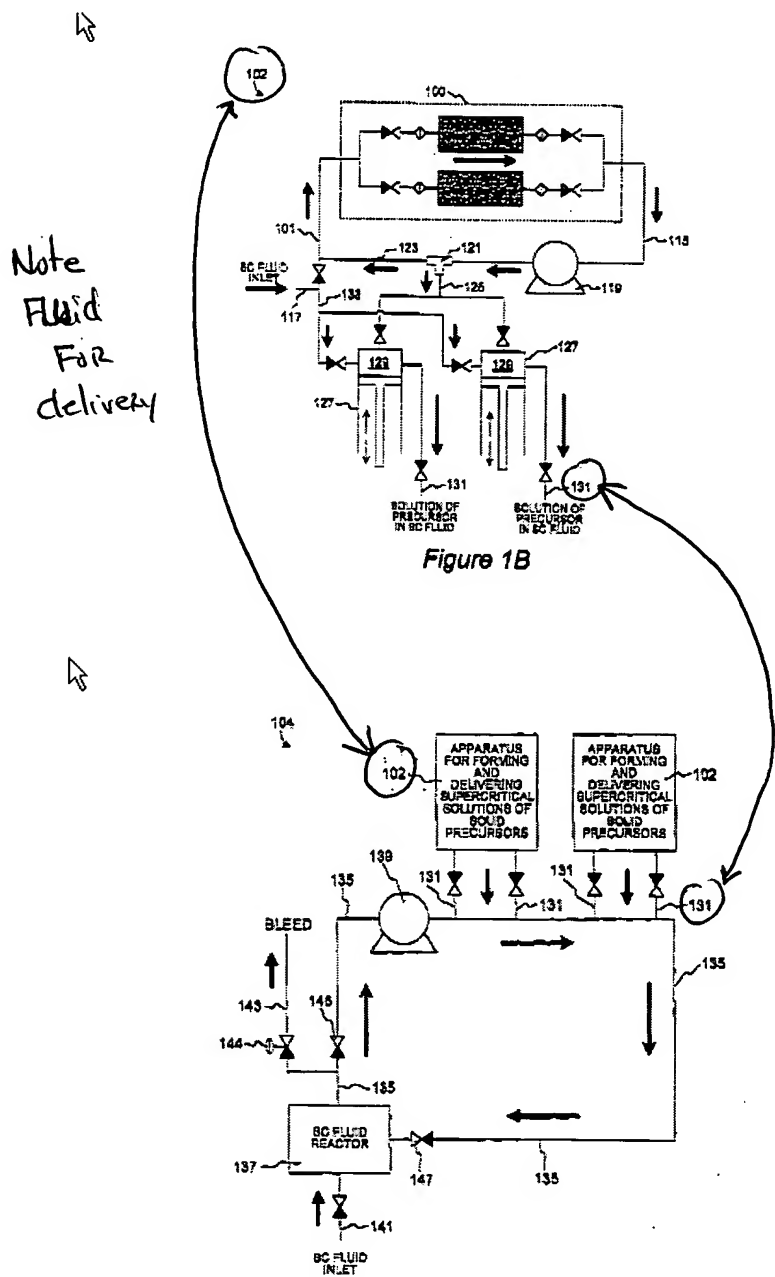
Re claim 1, Gopinath is cited disclosing an apparatus for use in a system for supercritical processing of an object with a fluid, comprising:

means (129, see fig. 1B above) for injecting a processing chemistry (the fluid in line 115) into the system for supercritical processing, including means for starting and means (syringe pump 129, 129) for stopping the means for injecting wherein the means for starting and the means for stopping comprises a flow-control means; and

means (check valve 131, see figs below) for substantially preventing fluid from re-entering the means for injecting during supercritical processing. That differs from the claims only in the recitation of the flow control means being comprised of at least one of a valve, a pneumatic actuator, an electric actuator, a hydraulic actuator, and a micro-electric actuator. Although not shown in Gopinath, means must obviously be provide for the pump (120) to operate and is therefore consider inherent. Nonetheless, Japan'679 discloses that is old and well known to provide a control means as claimed. It therefore would have been obvious to one having ordinary skill in the art to modify the

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arrangement of Gopinath, to include control means as taught by Japan'679, for the purpose of precisely controlling the injection of the additive.



Note input/delivery line 131

Figure 1C

Re claim 30 for example, note that

Gopinath discloses a supercritical processing system for processing a semiconductor

wafer with a fluid (see abstract), the fluid being from a fluid source (as at 141, see fig. 1C), the system comprising:

- a. a circulation loop (135) coupled to a high-pressure processing chamber (137); and
- b. an inlet line (as at 131) for introducing the fluid into the circulation loop, the inlet line including:
 - i. an inlet port in the circulation loop;
 - ii. a back-pressure regulator (unnumbered check valve in line 131) coupled to the inlet port;
 - iii. a pump (119, see fig. 1B) for compressing the fluid to form a pressurized fluid;
 - iv. a first line (125) for transferring the pressurized fluid from the pump to the back-pressure regulator, the first line configured to maintain a uni-directional flow of the pressurized fluid from the pump towards the back-pressure regulator; and
 - v. a second line (101, 115, see fig. 1B) for transferring a quantity of the fluid from the fluid source to the pump, the second line configured to maintain a uni-directional flow of the fluid from the fluid source to the pump.

2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

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3. Claims 2-5, 17 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gopinath et al. in view of DeYoung et al. (U. S. Pat. No.6,782,900). Claims 2, 3, 17 and 18 define over Gopinath only in the recitation of the predetermine pressure range as claimed. DeYoung is cited disclosing in a supercritical processing device (see abstract), the arrangement of employing a predetermined pressure range as claimed (col. 17, lines 18-21). It therefore would have been obvious to one having ordinary skill in the art to modify the device of Gopinath, to employ a predetermine pressure range as taught by DeYoung, since it is old and well known in cleaning devices to employ various pressures depending upon the type of contaminant to be removed, the type of object to be treated or the material used to clean the object for enhancing the cleaning process. Re claims 4 and 5, Gopinath discloses the back-flow prevention means as claimed.
4. Claims 6, 7, 21, 22, 24 and 26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gopinath et al. in view of Fan et al. (U. S. Pat. No. 5,620,524). Claims 6, 7, 9, 21, 22, 24 and 26 define over Gopinath only in the recitation of the flow-control means/back-pressure regulator as claimed. Fan (as at 10, 11) discloses the flow-control means as claimed. It therefore would have been obvious to one having ordinary skill in the art to modify the device of Gopinath, to include flow-control means as taught by fan, for the purpose of having the cleaning process operated fully automatic mode, thereby removing active human involvement and for precisely controlling the delivery of fluids to the chamber.

5. Applicant's arguments filed October 16, 2006 have been fully considered but they are not persuasive. In regard to the remarks that Gopinath has the pump (139) located "within" the loop, the examiner is in agreement with applicant's interpretation. However, as noted in the Office Action dated July 7, 2006, it is the pump "129" as indicated above is for introducing fluid into the loop/line 135.

5. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire **THREE MONTHS** from the mailing date of this action. In the event a first reply is filed within **TWO MONTHS** of the mailing date of this final action and the advisory action is not mailed until after the end of the **THREE-MONTH** shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than **SIX MONTHS** from the date of this final action.

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to **FRANKIE L. STINSON** whose telephone number is (571) 272-1308. The examiner can normally be reached on M-F from 5:30 am to 2:00 pm and some Saturdays from approximately 5:30 am to 11:30 am.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Barr, can be reached on (571) 272-1700. The fax phone number for the organization where this application or proceeding is assigned is 571-272-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

fls



FRANKIE L. STINSON
Primary Examiner
GROUP ART UNIT 1746